

Notice of References Cited	Application/Control No. 10/564,294		Applicant(s)/Patent Under Reexamination DE VAAN, ADRIANUS JOHANNE	
	Examiner LEAH S. LOVELL		Art Unit 2885	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-7,265,800	09-2007	Jagt et al.	349/61
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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